Intereby certify that this correspondence is being deposited with the United States Postal Service, with sufficient postage, as first class mail in an envelope addressed to: Commissioner for Patents Washington, D.C. 20231 on November 14, 2002 Date of Deposit Anastasia Heffner Name of applicant, assignee or Registered Representative Date of Signature

| Amend |B

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**TECHNOLOGY CENTER R3700** 

Our Case No. 7103/261 (P0704)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
Radman	)
Serial No. 09/843,323	) Examiner: M. Rachuba
Filing Date: April 25, 2001	) Group Art Unit No. 3723
For SPHERICAL CAP-SHAPED POLISHING HEAD IN A CHEMICAL MECHANICAL POLISHING APPARTUS FOR SEMICONDUCTOR WAFERS	) ) ) )

## **AMENDMENT**

Commissioner for Patents Washington, D.C. 20231

Dear Sir:

In response to the Office Action dated August 14, 2002, please enter the following amendment and consider the following remarks:

11/20/2002 MAHMED1 00000047 09843323

IN THE CLAIMS

01 FC:1201

84.00 DP

Please amend claims 1, 9 and 19 to read as follows: